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U. S. Patent Application Claiming Priority Of:

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Applicant: TAKAGI, et al.
For: VACUUM DEPOSITION METHOD AND SEALED-TYPE
EVAPORATION SOURCE APPARATUS FOR VACUUM
DE POSITION
Our File No.: 520514.00039

PRELIMINARY AMENDMENT

MAIL STOP PCT
Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

Sir:

Please enter into the record of the application filed herewith, the following amendments:

1. **Amendments to the Specification** begin on page 2 of this paper.
2. **Amendments to the Claims** are reflected in the listing of claims which begins on page 3 of this paper.
3. **Remarks** begin on page 7 of this paper.